



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants: M. HATANO, et al.  
Application No.: 10/670,356  
Filed: September 26, 2003  
For: THIN FILM SEMICONDUCTOR DEVICE,  
POLYCRYSTALLINE SEMICONDUCTOR THIN FILM  
PRODUCTION PROCESS AND PRODUCTION APPARATUS  
Art Unit: 2813  
Examiner: T. NGUYEN

**REQUEST FOR PETITION FOR EXTENSION OF TIME**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

May 5, 2006

Sir:

In the matter of the above-identified application, Applicants hereby respectfully petition for an extension of time to permit filing a response within a two-month time period subsequent to expiration of the shortened statutory period set in the outstanding Office Action mailed December 5, 2005. A credit card payment form in the amount of \$450.00 to cover the required fee for the requested extension of time is attached hereto.

It is respectfully requested that any shortage in the fee be charged to the deposit account of Antonelli, Terry, Stout & Kraus, LLP, Account No. 01-2135 (Docket No. 520.39728VX1) and any excess fees credited to that account.

Respectfully submitted,  
**ANTONELLI, TERRY, STOUT & KRAUS, LLP**

  
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Gregory E. Montone  
Reg. No. 28,141

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